## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori, et al.

Art Unit : 2822

Serial No.: 10/713,275

Examiner: Kiesha L. Rose

: November 17, 2003 Conf. No. : 1472 Filed

: METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF

MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM

TRANSISTOR

## Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Title

Alexandria, VA 22313-1450

## AMENDMENT IN REPLY TO ACTION OF APRIL 21, 2006

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.